

Docket No.: 123037-06066007

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Ae-Kyoung LEE et al.

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: *Confirmation No. 5526*

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U.S. Patent Application No. 10/580,462

: Group Art Unit: 2821

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Filed: May 25, 2006

: Examiner: Hoang Nguyen V.

For: METHOD FOR MEASURING ELECTROMAGNETIC RADIATION PATTERN AND
GAIN OF RADIATOR USING TEM WAVEGUID

LETTER SUBMITTING SUBSTITUTE DECLARATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith is the Substitute Oath/Declaration as required by the Examiner on
September 18, 2007 in connection with the above referenced application.

Entry is respectfully requested.

Respectfully submitted,

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